

## **PALM INTRANET**

Day : Monday Date: 12/22/2003 Time: 14:47:14

## **Inventor Name Search Result**

Your Search was:

Last Name = MUNAKATA First Name = HIDEKI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
09926173	Not Issued	030		WAFER CONTAINER AND DUSTING PREVENTION METHOD THEREOF AND METHOD FOR CONTAINING WAFER	MUNAKATA, HIDEKI
09719564	6558233	150		WAFER POLISHING METHOD, WAFER CLEANING METHOD AND WAFER PROTECTIVE FILM	MUNAKATA, HIDEKI
08901166	6125554	150		METHOD AND APPARATUS FOR DRYING FLAT OBJECTS	MUNAKATA , HIDEKI
08374188	5540245	150		PROCESSING EQUIPMENT OF SINGLE SUBSTRATE TRANSFER TYPE	MUNAKATA, HIDEKI

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